



00862.021811

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

TADAHIRO OHMI, ET AL.

Application No.: 09/494,945

Filed: February 1, 2000

For: LASER OSCILLATING APPARATUS,
EXPOSURE APPARATUS USING
THE SAME, AND DEVICE
FABRICATION METHOD

Examiner: D. Florez Ruiz

Group Art Unit: 2828

December 8, 2003

THE COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Official Action mailed September 8, 2003, the Examiner is respectfully requested to consider and enter the following amendments.

RECEIVED

DEC 11 2003

TECHNOLOGY CENTER 2800